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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of			
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	Complete if Known					
	Application Number	10/541,071				
	Filing Date	April 5, 2006				
	First Named Inventor	Daniele FACCIO et al.				
	Art Unit	2874				
	Examiner Name	Kim, Ellen E.				
_	Attorney Docket Number	05788.0373-00000				

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS						
Examiner	Cite	Document Number	Issue or	Name of Patentee or	Pages, Columns, Lines, Where	
Initials	No. <sup>1</sup>	Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Relevant Passages or Relevant Figures Appear	
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FOREIGN PATENT DOCUMENTS						
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	NON PATENT LITERATURE DOCUMENTS				
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		P.P. Absil et al., "Compact Microring Notch Filters," IEEE Photonics Technology Letters, Vol. 12, No. 4, pp. 398-400, April 2000.			

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